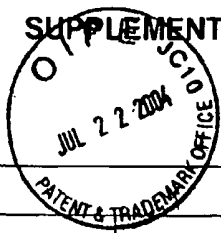


<b>INFORMATION DISCLOSURE CITATION</b>  <b>SUPPLEMENTAL PTO-1449</b>  		ATTY. DOCKET NO. 07783.0014.CNUS03		SERIAL NO. 10/621,192			
		APPLICANT Chen					
		FILING DATE 7/15/2003		GROUP 2873			
<b>U.S. PATENT DOCUMENTS</b>							
EX'R INITIAL	PATENT NO.	DATE MM-YYYY	NAME	CLASS	SUBCLASS	FILING DATE	
<i>W. W. W.</i>	5,182,332	01-1993	Yamamoto et al	—	—		
<i>W. W. W.</i>	6,287,490	09-2001	Rheinberger et al	—	—		
<b>FOREIGN PATENT DOCUMENTS</b>							
EX'R INITIAL	PATENT NO.	DATE MM-YYYY	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						YES	NO
<b>OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)</b>							
EX'R INITIAL	DOCUMENT						
EXAMINER: <i>Wm. W. W.</i> DATE CONSIDERED: <i>9-7-04</i>							
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*If an asterisk is placed beside the reference number, a copy is not provided because the reference was previously cited by or submitted to the PTO in a prior application that is identical in the statement and relied upon for an earlier filing date under 35 U.S.C. §120. 37 C.F.R. §1.98 (d).							

<b>INFORMATION DISCLOSURE CITATION</b>  <b>PTO-1449</b>		<b>ATTY. DOCKET NO.</b> 26822-0014 C1		<b>SERIAL NO.</b> To be assigned (Cont. of 09/840,756)			
		<b>APPLICANT</b> Chen, et al.					
		<b>FILING DATE</b> 07/15/2003		<b>GROUP</b> to be assigned			
<b>U.S. PATENT DOCUMENTS</b>							
<b>EXAMINER'S INITIALS</b>	<b>PATENT NO.</b>	<b>DATE</b>	<b>NAME</b>	<b>CLASS</b>	<b>SUBCLASS</b>	<b>FILING DATE</b>	
M.A.M.	3,612,758	10/12/71	Evans et al.	178	5.4 R		
	3,668,106	06/06/72	Ota	204	299		
	3,697,679	10/10/72	Hathaway	178	6.6 A		
	4,071,430	01/31/78	Liebert	204	299		
	4,093,534	06/06/78	Carter et al.	350	355		
	4,285,801	08/25/81	Chiang	204	299		
	4,680,103	07/14/87	Beilin Solomon I, et al.	204	299		
	4,741,988	05/03/88	Van der Zande et al.	430	312		
	4,995,718	02/26/91	Jachimowicz et al.	353	31		
	5,276,438	01/04/94	DiSanto et al.	345	107		
M.A.M.	2002/018043	02/14/02	Nakanishi				
<b>FOREIGN PATENT DOCUMENTS</b>							
<b>EXAMINER'S INITIALS</b>	<b>PATENT NO.</b>	<b>DATE</b>	<b>COUNTRY</b>	<b>CLASS</b>	<b>SUBCLASS</b>	<b>TRANSLATION</b>	
						<b>YES</b>	<b>NO</b>
M.A.M.	WO 99/56171	11/4/99	PCT	G02F	1/167	<input type="checkbox"/>	<input type="checkbox"/>
	WO 00/60410	10/12/00	PCT	G02F	1/167	<input type="checkbox"/>	<input type="checkbox"/>
	WO 01/67170	09/13/01	PCT	G02F	1/167	<input type="checkbox"/>	<input type="checkbox"/>
	1 089 118 A2	04/04/01	Europe	G02F	1/167	<input type="checkbox"/>	<input type="checkbox"/>
M.A.M.	59-171930	09/28/84	Japan	G02F	1/19	<input type="checkbox"/>	<input type="checkbox"/>
<b>OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)</b>							
M.A.M.	Cominsky, B. et al., "An Electrophoretic Ink For All-Printed Reflective Electronic Displays", LETTERS TO NATURE, pp. 253-255 (1998)						
	Dalisa, A.L., "Electrophoretic Display Technology", IEEE TRANSACTIONS OF ELECTRON DEVICES, July 1997, pp. 827-834.						
M.A.M.	Drzaic, P., "Liquid Crystal Dispersion", THE PDLIC PARADIGM, (1995), pp. 1-9.						
	Harbour, J.R. et al., "Subdivided Electrophoretic Display", XEROX DISCLOSURE JOURNAL, Vol. 4, No. 6 (1979)						
<b>EXAMINER</b> M.A. Matheson		<b>DATE CONSIDERED</b> 9-7-04					

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<b>INFORMATION DISCLOSURE CITATION</b>  <b>PTO-1449</b>		ATTY. DOCKET NO. 26822-0014 C1		SERIAL NO. To be assigned			
		APPLICANT Chen, et al.					
		FILING DATE 07/15/03		GROUP To be assigned			
<b>U.S. PATENT DOCUMENTS</b>							
EXAMINER'S INITIALS	PATENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE	
M.A.T.D.	5,279,511	01/18/94	DiSanto et al.	445	24		
	5,380,362	01/10/95	Schubert	106	493		
	5,403,518	04/04/95	Schubert	252	572		
	5,573,711	11/12/96	Hou et al.	252	572		
	5,589,100	12/31/96	Grasso et al.	252	299.01		
	5,699,097	12/16/97	Takayama et al.	347	171		
	5,835,174	11/10/98	Clikeman et al.	349	86		
M.A.T.D.	5,914,806	06/22/99	Gordon, II et al.	359	296		
<b>FOREIGN PATENT DOCUMENTS</b>							
EXAMINER'S INITIALS	PATENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						YES	NO
M.A.T.D.	1 195 603 A2	4/2002	EPO	—	—	<input type="checkbox"/>	<input type="checkbox"/>
	002284126	11/1990	Japan (Abstract) and XP-002211269	—	—	<input checked="" type="checkbox"/>	<input type="checkbox"/>
M.A.T.D.	056653	2/27/01	Japan	—	—	<input checked="" type="checkbox"/>	<input type="checkbox"/>
<b>OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)</b>							
M.A.T.D.	Lewis, J.C., et al., "Gravitational, Inter-Particle-Electrode Forces in Electrophoretic Display", PROCEEDINGS OF THE S.I.D., Vol. 18/3&4 (1977)						
	Murau, P., et al., "The Understanding and Elimination of Some Suspension Instabilities in an Electrophoretic Display", J. APPL. PHYS., 49(9), (1978)						
	Nakamura, E., et al., "Development of Electrophoretic Display Using Microcapsulated Suspension", SID DIGEST, (1998), PP. 1014-1017						
M.A.T.D.	Ota, I., et al., "Electrophoretic Image Display EPID Panel", PROCEEDINGS OF THE IEEE, Vol. 1, No. 7, July 1973.						
	Singer, B. and Dalisa, A.L., "An X-Y Addressable Electrophoretic Display", PROCEEDING OF THE S.I.D., Vol. 18/3&4, (1977)						
EXAMINER			DATE CONSIDERED				
M.A.T.D.			9-7-04				

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<b>INFORMATION DISCLOSURE CITATION</b>  <b>PTO-1449</b>			ATTY. DOCKET NO. 26822-0014 C1		SERIAL NO. To be assigned	
			APPLICANT Chen, et al.			
			FILING DATE 07/15/03		GROUP To be assigned	
<b>U.S. PATENT DOCUMENTS</b>						
EXAMINER'S INITIALS	PATENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE
<i>W.A.M.D.</i>	5,976,405	11/02/99	Clikeman et al.	252	299.01	
	6,017,584	01/25/00	Albert et al.	427	213.3	
	6,037,058	03/14/00	Clikeman et al.	428	402.2	
	6,067,185	05/23/00	Albert et al.	359	296	
	6,111,598	08/29/00	Faris	348	57	
	6,113,810	09/05/00	Hou et al.	252	572	
	6,120,588	09/19/00	Jacobson	106	31.16	
	6,120,839	09/19/00	Comiskey	427	213.3	
	6,172,798	01/09/01	Albert et al.	359	296	
	6,184,856	02/06/01	Gordon, II et al.	345	107	
	6,252,624	06/26/01	Yuasa et al.	348	56	
	6,312,304	11/06/01	Duthaler et al.	445	24	
	6,327,072	12/04/01	Comiskey et al.	359	296	
	6,337,761	01/08/02	Rogers et al.	359	296	
<i>W.A.M.D.</i>	6,392,786	05/21/02	Albert	359	296	
<b>OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)</b>						
<i>W.A.M.D.</i>	Harvey, T.G., "Replication techniques for micro-optics", <i>SPIE Proc.</i> - 3099:76-82 (1997)					
	Hopper, M.A., et al., "An Electrophoretic Display, its Properties, Models and Addressing", <i>IEEE Trans. Electr. Dev.</i> - 26(8):1148-1152 (1979)					
<i>W.A.M.D.</i>	Slafer, W.D., et al., "Continuous Manufacturing of Thin Cover Sheet Optical Media", <i>SPIE Proc.</i> - 1663:324-334 (1992)					
EXAMINER <i>Wm. McEwen</i>			DATE CONSIDERED <i>9-7-04</i>			

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